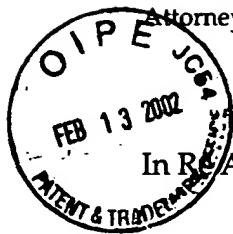


2811

#5/Election

3/4/02

VS



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven N. Towle et al.

U.S. Serial No: 09/639,625

Filed: August 15, 2000

For: PLASMA INDUCED DEPLETION
OF FLUORINE FROM SURFACES OF
FLUORINATED LOW-K DIELECTRIC
MATERIALS

Commissioner of
Patents and Trademarks
Washington, D.C. 20231

Examiner: Owens, D.

Art Unit: 2811

TC 2800 MAIL ROOM

FEB 19 2002

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I hereby certify that this correspondence is being deposited
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on January 10, 2002

Date of Deposit

Name of Person Mailing Correspondence

Signature

Date

RESPONSE TO ELECTION REQUIREMENT

Sir:

In response to the Election Requirement mailed December 28, 2001, applicant(s)
hereby elects to prosecute Group II claims, claims 1-17 drawn to a method of forming a
semiconductor device. As such, applicant(s) elects to withdraw Group I claims, claims
18-20 drawn to a semiconductor device.

If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date:

1/10/02

Michael A. Bernadicou
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